

Notice of References Cited	Application/Control No. 09/998,123	Applicant(s)/Patent Under Reexamination LIEM ET AL.	
	Examiner A. Dexter Tugbang	Art Unit 3729	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,090,147	07-2000	Bremner et al.	703/1
	B	US-6,091,578	07-2000	Stole et al.	360/265.9
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 99/09544	02-1999	PCT	Stole et al	-
	O					
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	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kugel et al, "Behavior of Piezoelectric Actuators under High Electric Field", IEEE Transactions on Ferroelectrics, Vol. 2, pages 655-658, August 1996.
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.